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January 9, 2004

Customer No.

23911

Mail Stop: Patent Application

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Re: New U.S. Patent Appln. Our Ref: 056203.53141US

Sir:

Transmitted herewith for filing is the patent application of:

Masayuki KOBAYASHI, Kouji HARADA, Hiroatsu TOKUDA and Kazuo OJIMA

Entitled: WORKING METHOD OF METAL MATERIAL AND SEMICONDUCTOR APPARATUS FABRICATED BY THE METHOD

Enclosed are:

- 1. Specification, including <u>15</u> claims (<u>24</u> pages).
- 2. <u>7</u> Sheets of Formal Drawings Showing Figs. 1-13.
- 3. Declaration and Power of Attorney (Executed).
- 4. Application Data Sheet
- 5. Assignment of the invention to Hitachi, Ltd. Tokyo, Japan
- 6. Priority is being claimed under 35 U.S.C. §119 and 37 C.F.R. §1.55 based on Priority Document 2003-018185, filed in Japan on January 28, 2003.
- 7. Information Disclosure Statement w/2 references.
- 8. The filing fee has been calculated as shown below:

Basic Fee \$\$385/770 = \$770.00\$

Total Claims
$$15 - 20 = 0 \times $9/18 = $$$
Independent Claims $3 - 5 = 0 \times $140/280 = $$
Multiple Dependent Claim Presented $$770.00$

Two checks in the amount of \$770.00 for the filing fee and \$40.00 for the assignment recording fee are enclosed. The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Deposit Account No. 05-1323 (Docket #056203.53141US). A duplicate copy of this sheet is enclosed.

Respectfully submitted,

James F. McKeown

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JFM:LEC:adb Document#298240